

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)
)
Satoshi Murakami, et al.)
)
Serial No: 09/516,082)
)
Filed: March 1, 2000)
)
Art Unit: 2815)
)
Confirmation No.: 3545)
)
Examiner: Eugene Lee)
)
For: Semiconductor Device Comprising A)
Thin Film Transistor Comprising A)
Semiconductor Thin Film And Method)
Of Manufacturing The Same)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT N (AFTER ALLOWANCE)

Dear Sir:

In furtherance of the Notice of Allowance of April 14, 2009, a RCE and an IDS being submitted herewith, please amend the above-identified application as follows: